

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Isabelle Chartier et al.  
SERIAL NO.: 10/560,405  
FILING DATE: December 12, 2005 CONFIRMATION NO.: 5533  
TITLE: Method Of Bonding Microstructured Substrates  
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**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Dear Sir:

This paper is responsive to the Office Action mailed **August 31, 2009**. Please amend the above-identified application as follows:

**Amendments to the Specification** begins on page **2** of this paper.

**Amendments to the Claims** begins on page **3** of this paper.

**Remarks** begin on page **8** of this paper.